



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

0.681764  
#61B  
11.29.00

In re the application of

EIPEL et al.

Serial No.: 09/241,868

Filed: January 14, 1999

For: SOLID SUPPORTS FOR ANALYTICAL MEASUREMENT METHODS, AND THEIR PRODUCTION AND THEIR USE

Group No. 1743

Examiner: L. Alexander

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Honorable Commissioner of  
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### AMENDMENT

Sir:

In response to the office action of August 18, 2000, kindly amend the above-identified application as follows.

### IN THE CLAIMS

Please amend claims 1 and 8 as follows.

1.(amended) A solid support for analytical measurement methods which is essentially composed of an inert solid support material on which hydrophilic measurement zones [which may be provided with a surface loading] are separated from one another by at least one non-continuous hydrophobic coating, where the number of measurement points applied per cm<sup>2</sup> of the support is greater than or equal to 10.